

Notice of References Cited	Application/Control No. 10/669,384	Applicant(s)/Patent Under Reexamination BASCERI ET AL.	
	Examiner Mark D. Pe	Art Unit 2811	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,417,537	07-2002	Yang et al.	257/310
	B	US-6,403,444	06-2002	Fukuzumi et al.	438/396
	C	US-6,432,793	08-2002	Reinberg, Alan R.	438/396
	D	US-6,140,175	10-2000	Kleinhenz et al.	438/243
	E	US-6,673,689	01-2004	Al-Shareef et al.	438/381
	F	US-6,159,849	12-2000	Kang et al.	438/665
	G	US-5,723,171	03-1998	Cuchiaro et al.	427/97.4
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf and R.N. Tauber, Silicon Processing for the VLSI Era, 1986, Lattice Press, Volume 1, pp: 44 and 2
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.